

Electronic Acknowledgement Receipt

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Application Number:	09546174
International Application Number:	
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Title of Invention:	HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS
First Named Inventor/Applicant Name:	Chih-Chien Liu
Customer Number:	26021
Filer:	William H. Wright/Lillian Rodriguez
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part/.zip	Pages (if appl.)
1	Appeal Brief Filed	20952-4002-AppealBrief.pdf	1359565 7137bcbefadaf555a4c8cb1e195fc3f83f4a0 db3	no	42

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